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09/802,726

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Hadizad et al.  
Serial No.: 09/802,726  
Filing Date: March 12, 2001  
Group Art Unit: 2813  
Examiner: Schillinger, Laura M  
Title: SEMICONDUCTOR COMPONENT AND METHOD  
OF MAKING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING FACSIMILE  
TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE, ATTN EXAMINER  
Laura M. Schillinger, AT THE FAX NO. (703) 872-9316

ON:

July 31, 2003

7 pages

Date of Facsimile Transmission

Lydia McNamara

Name of Person Signing Certificate

Lydia McNamara

7-31-03

SIGNATURE

DATE

Honorable Commissioner of Patents,  
Washington, D.C. 20231

PRELIMINARY AMENDMENT

SIR:

Applicants respectfully request entry of this  
Preliminary Amendment and that the herein changes be  
incorporated prior to examination.

08/15/2003 SDAVIS

01 FC:1201  
02 FC:1202

168.00 DA  
36.00 DA

08/15/2003 SRB/MS 00000004 501086  
110.00 DA  
01 FC:1251

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JUL 31 2003

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